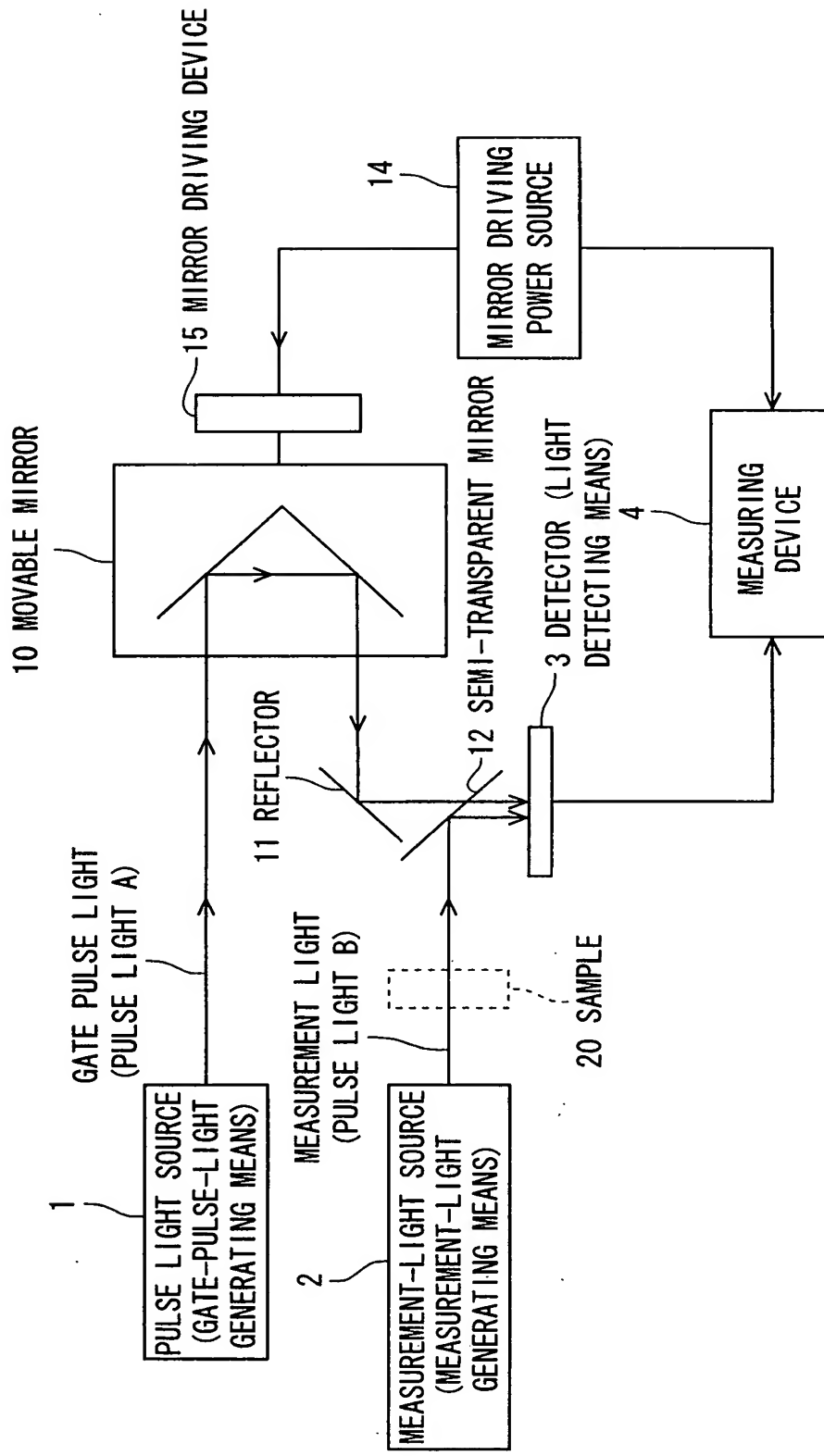
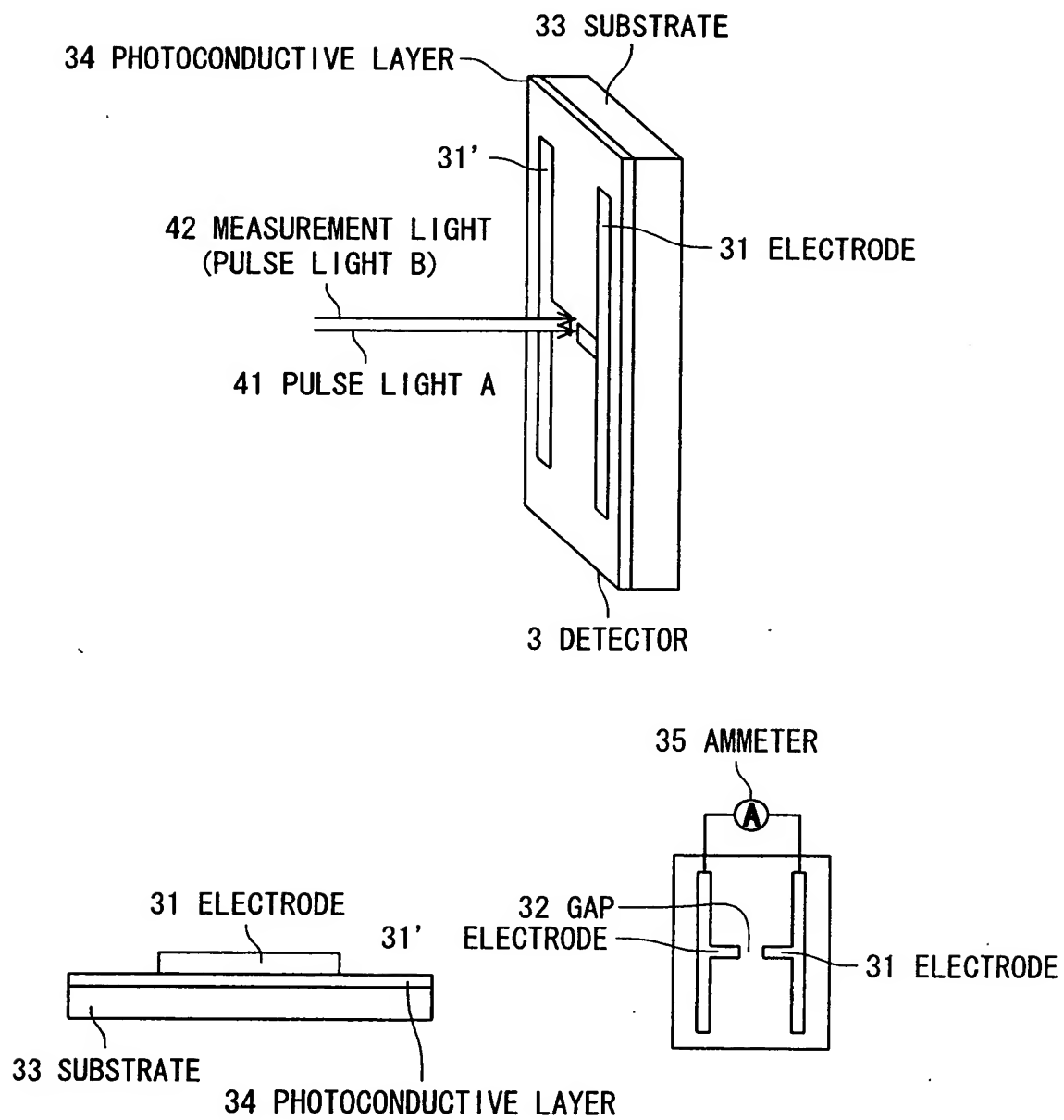


【図1】

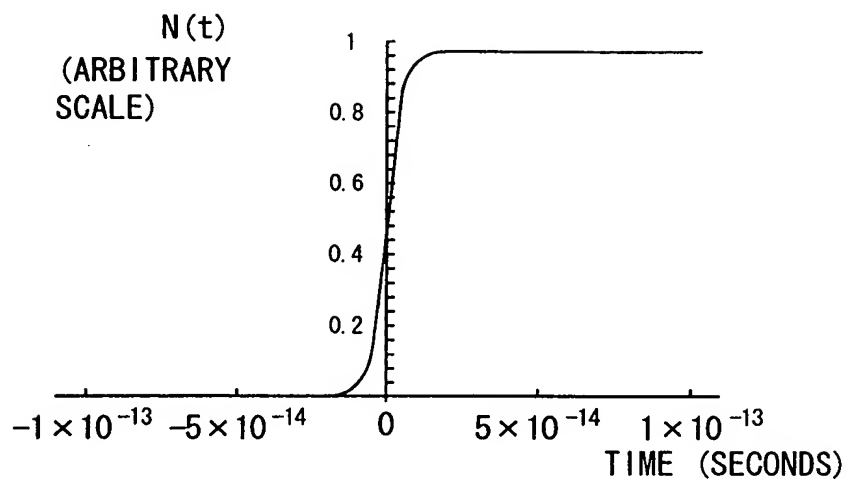
FIRST EMBODIMENT OF THE INVENTION



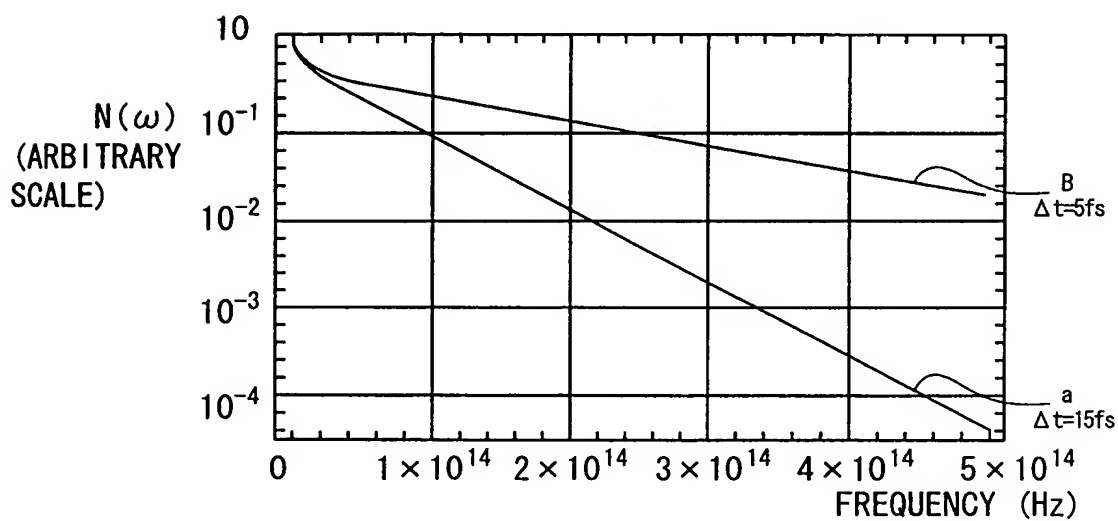
EMBODIMENT OF DETECTOR OF THE INVENTION



EXPLANATION VIEW OF PULSE WIDTH OF GATE PULSE LIGHT FOR REALIZING T



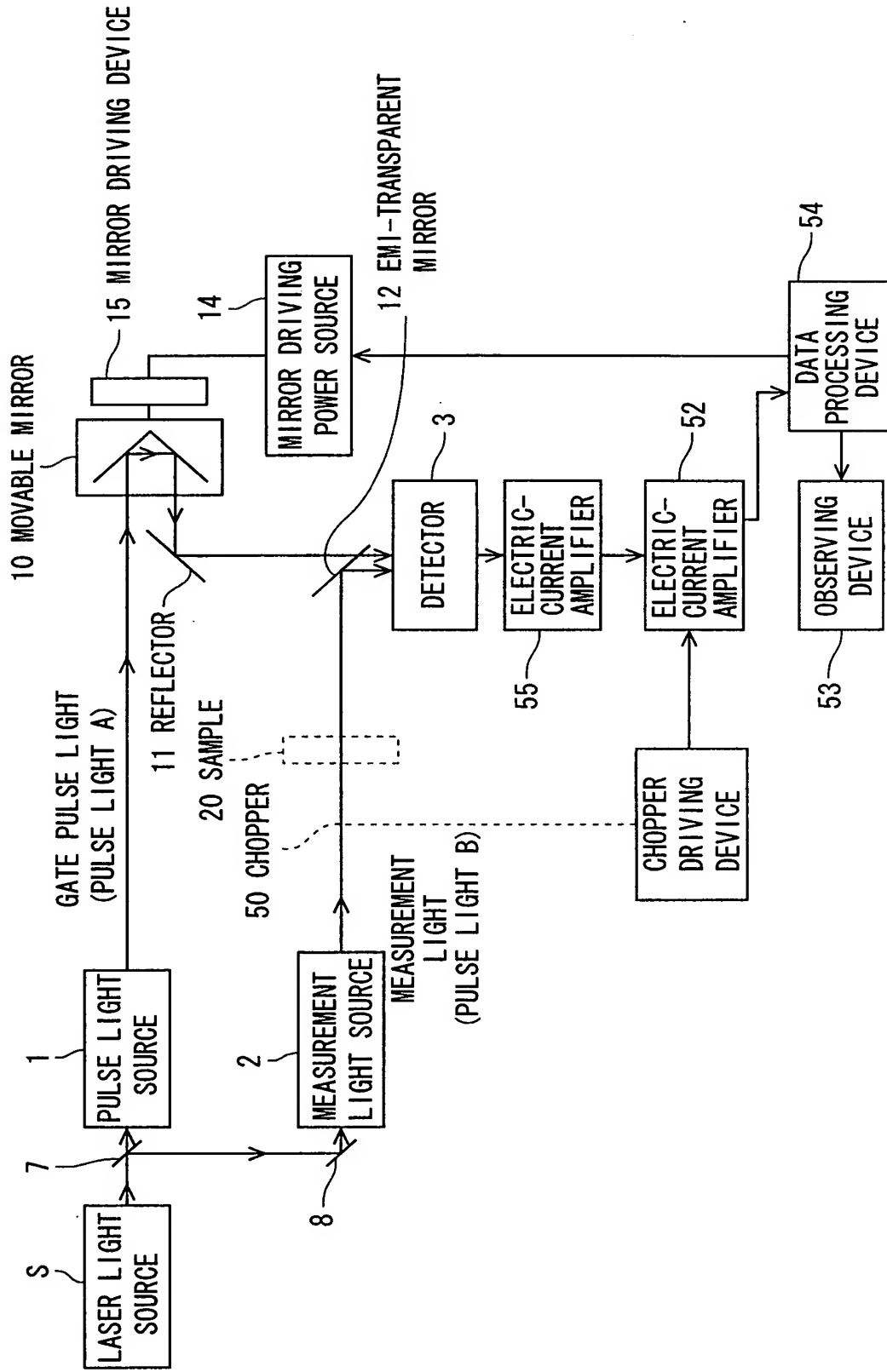
(a)



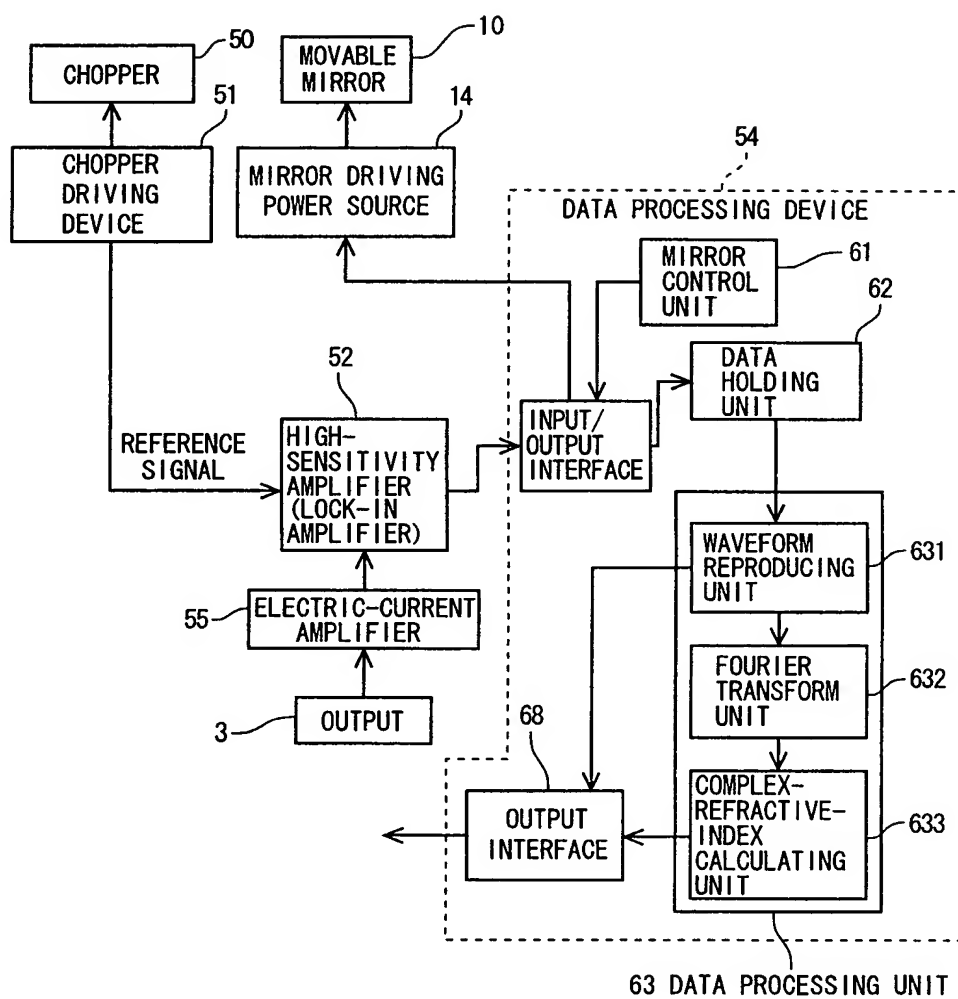
(b)

【図4】

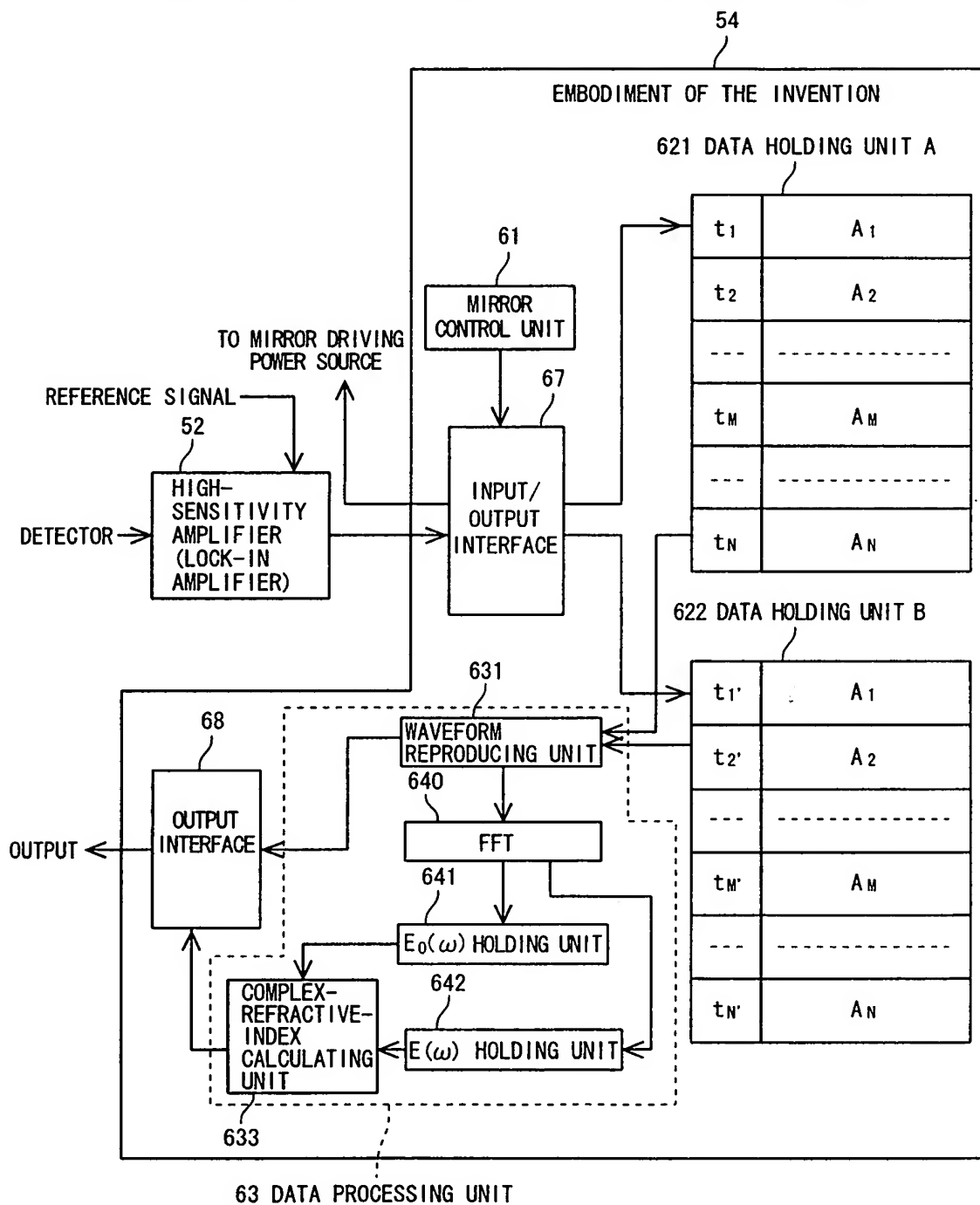
SECOND EMBODIMENT OF THE INVENTION



SYSTEM CONFIGURATION ACCORDING TO SECOND EMBODIMENT OF THE INVENTION

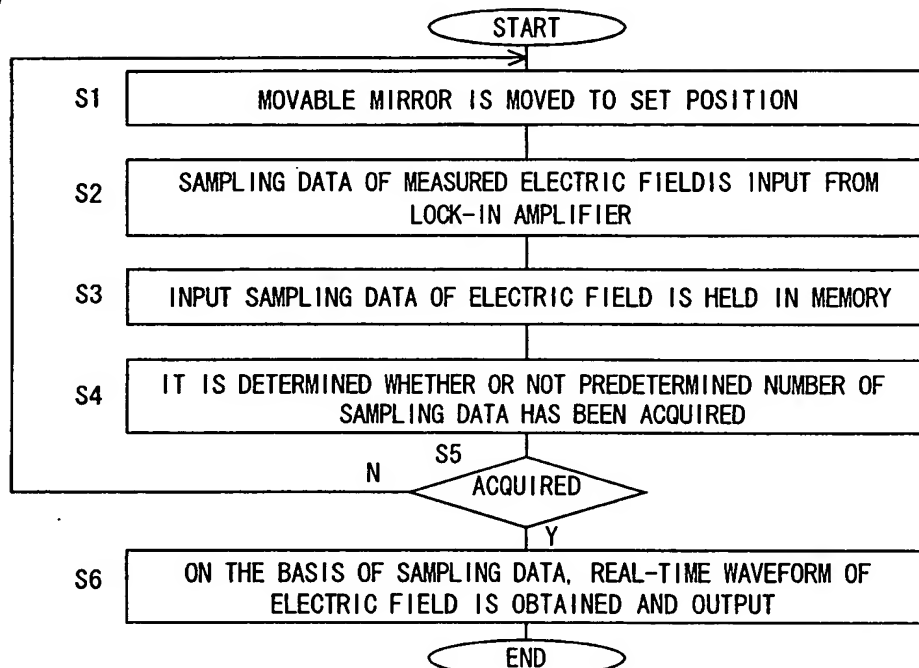


CONFIGURATION OF DATA PROCESSING DEVICE ACCORDING TO SECOND

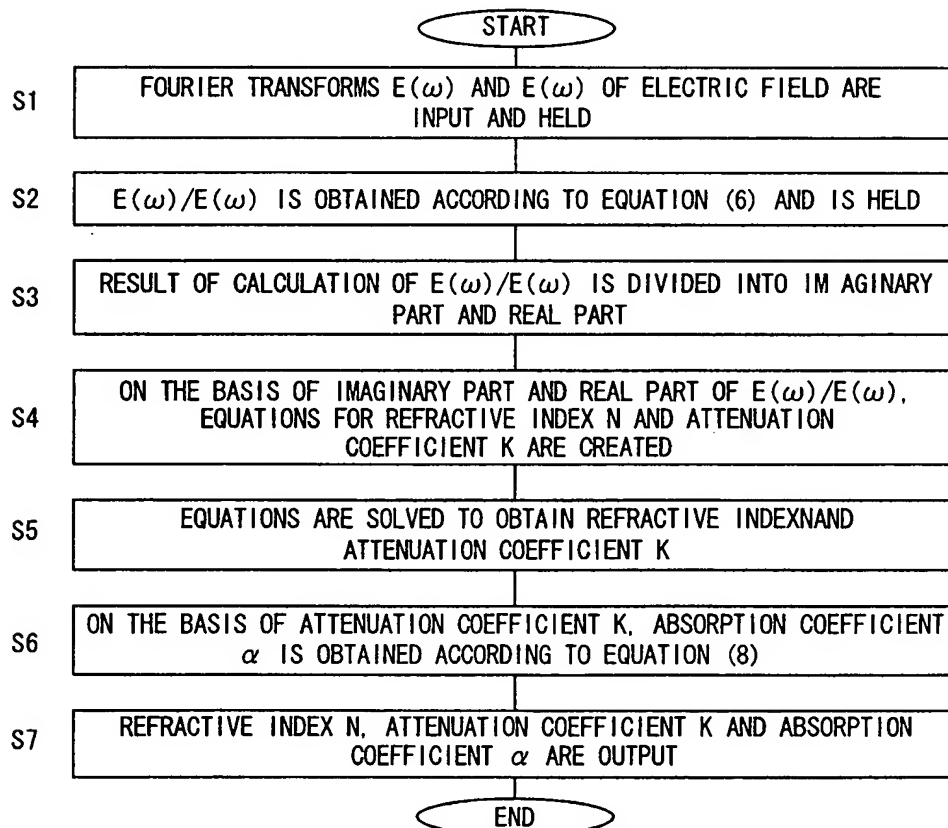


FLOW CHART IN DATA PROCESSING DEVICE ACCORDING TO SECOND EMBODIMENT OF THE INVENTION

(a)

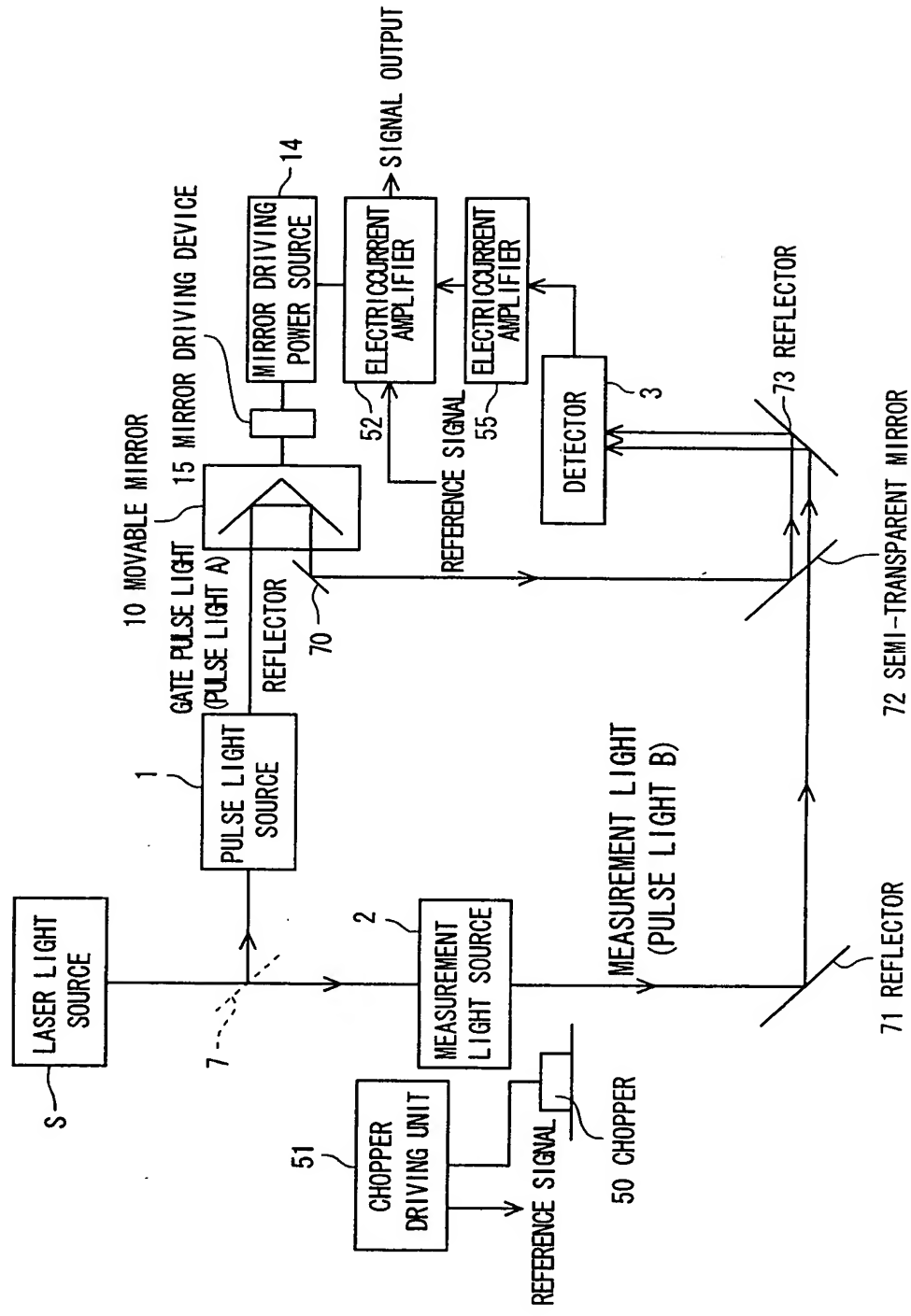


(b)



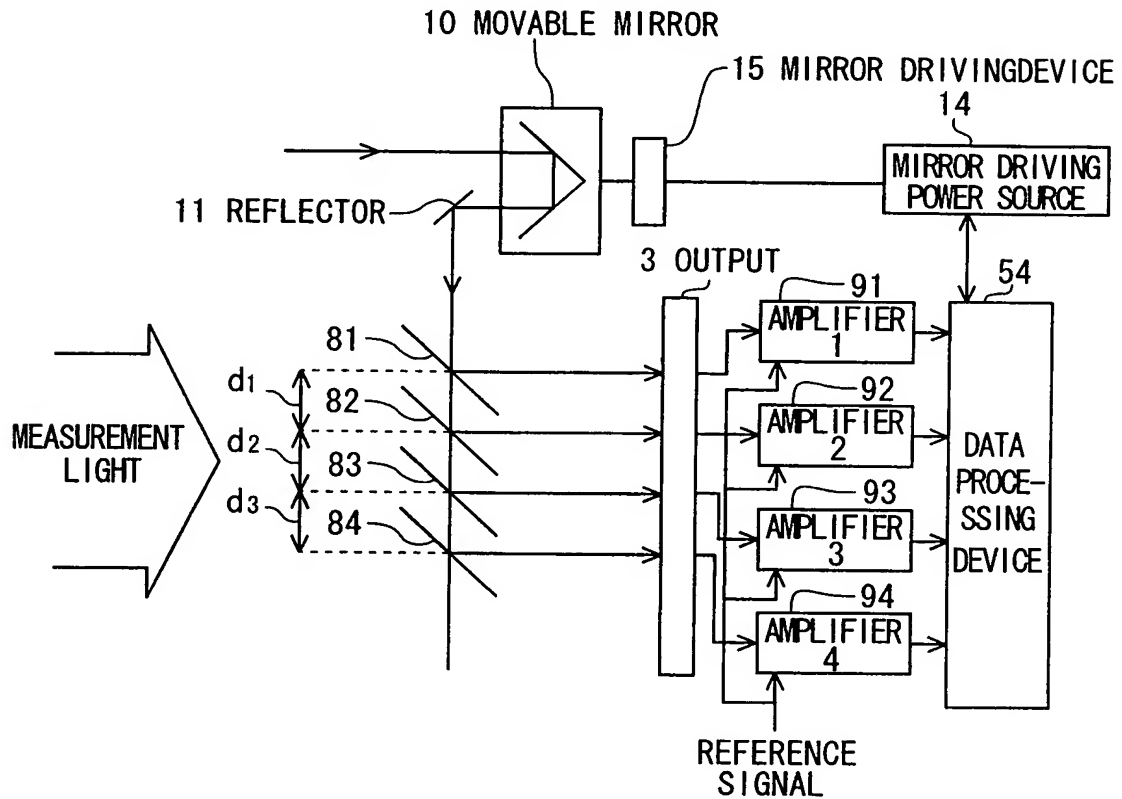
【図8】

THIRD EMBODIMENT OF THE INVENTION

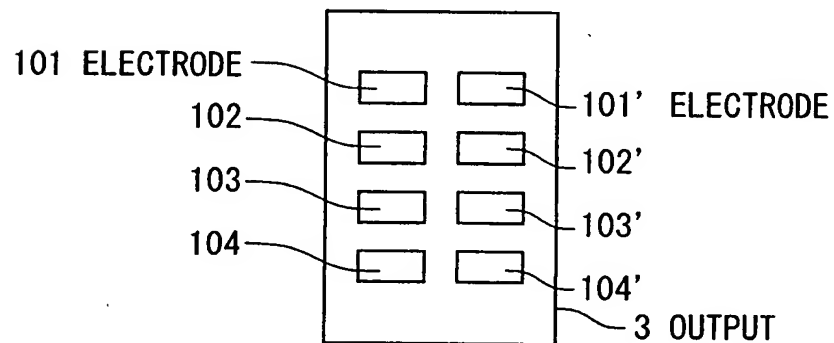


FOURTH EMBODIMENT OF THE INVENTION
FIRST METHOD FOR PERFORMING MEASUREMENT FOR PLURAL OPTICAL-PATH
DIFFERENCES THROUGH SINGLE IRRADIATION OF GATE PULSE LIGHT

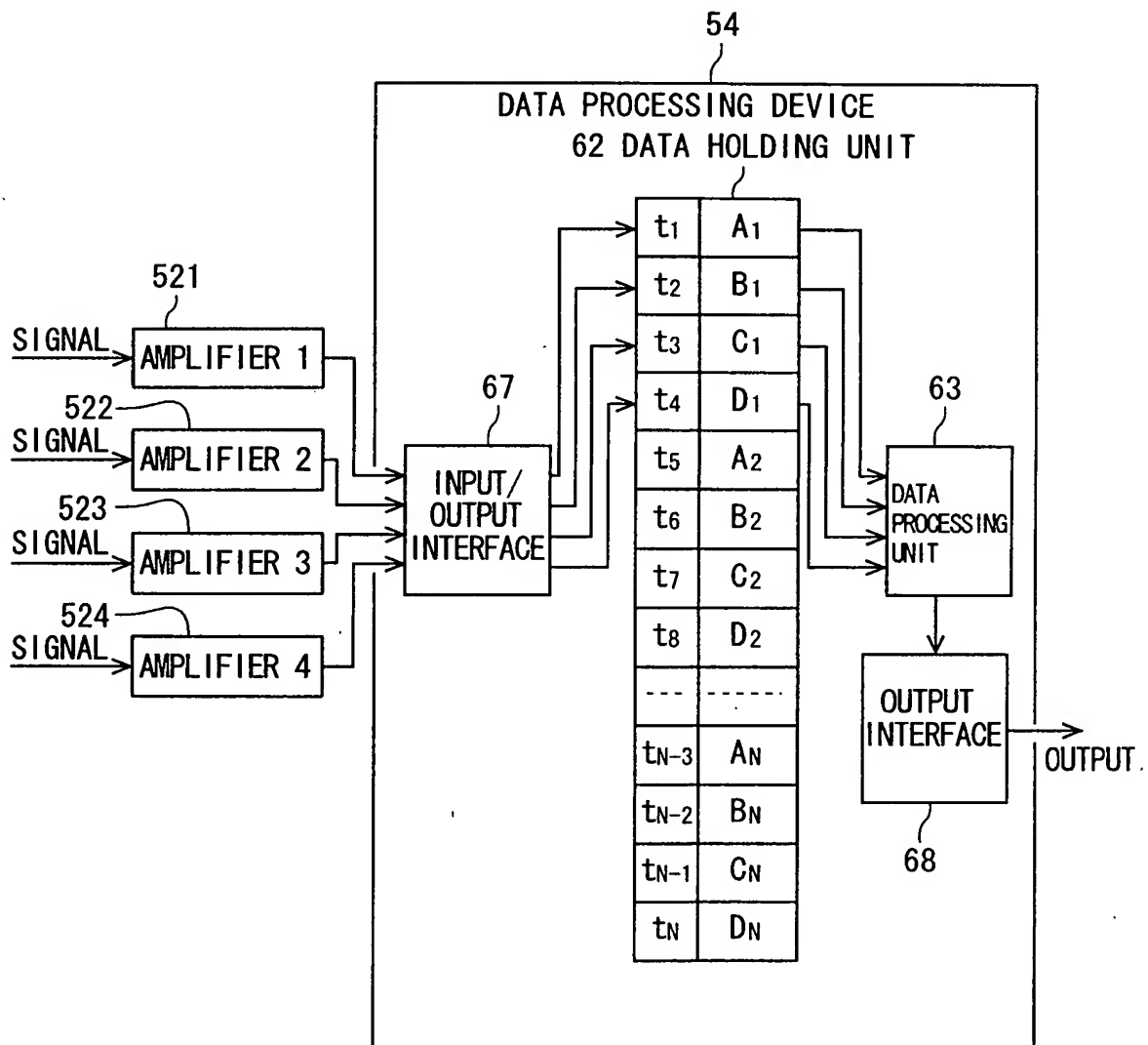
(a)



(b)

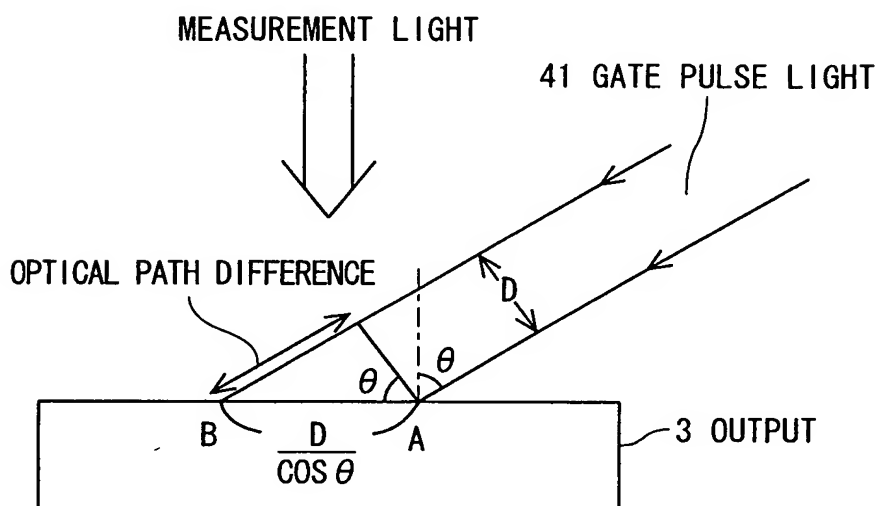


CONFIGURATION OF DATA PROCESSING DEVICE ACCORDING TO FOURTH EMBODIMENT OF THE INVENTION

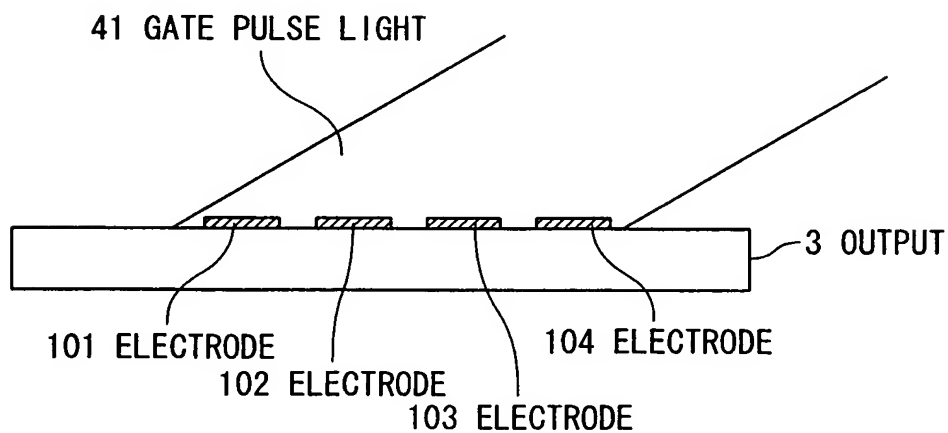


FOURTH EMBODIMENT
(SECOND METHOD FOR PERFORMING MEASUREMENT FOR PLURAL OPTICAL-PATH
DIFFERENCES THROUGH SINGLE IRRADIATION OF GATE PULSE)

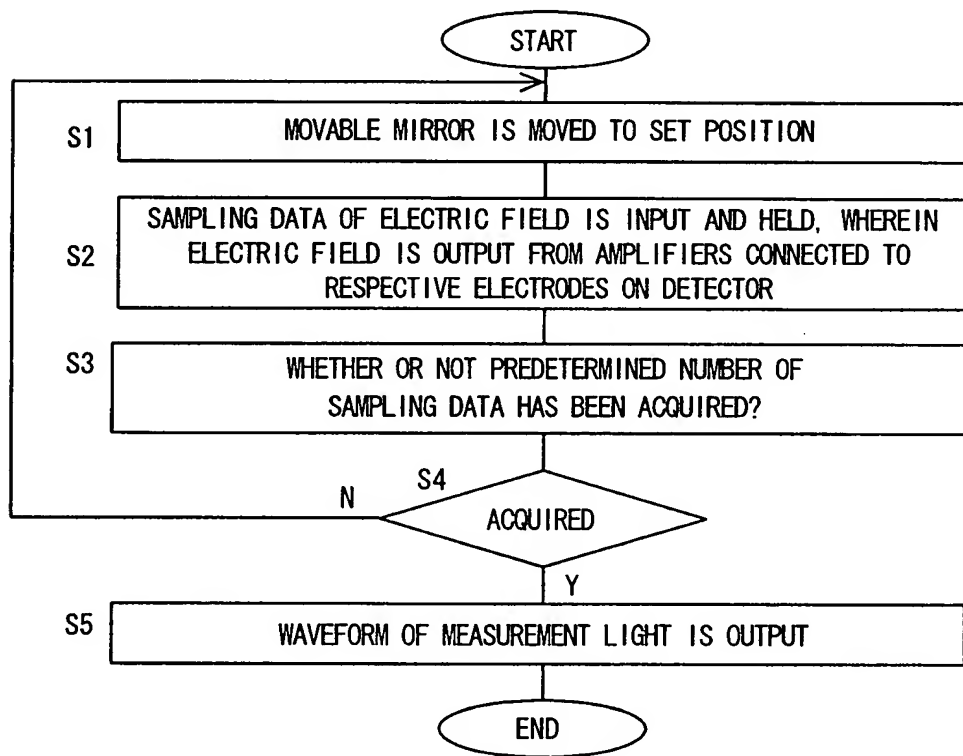
(a)



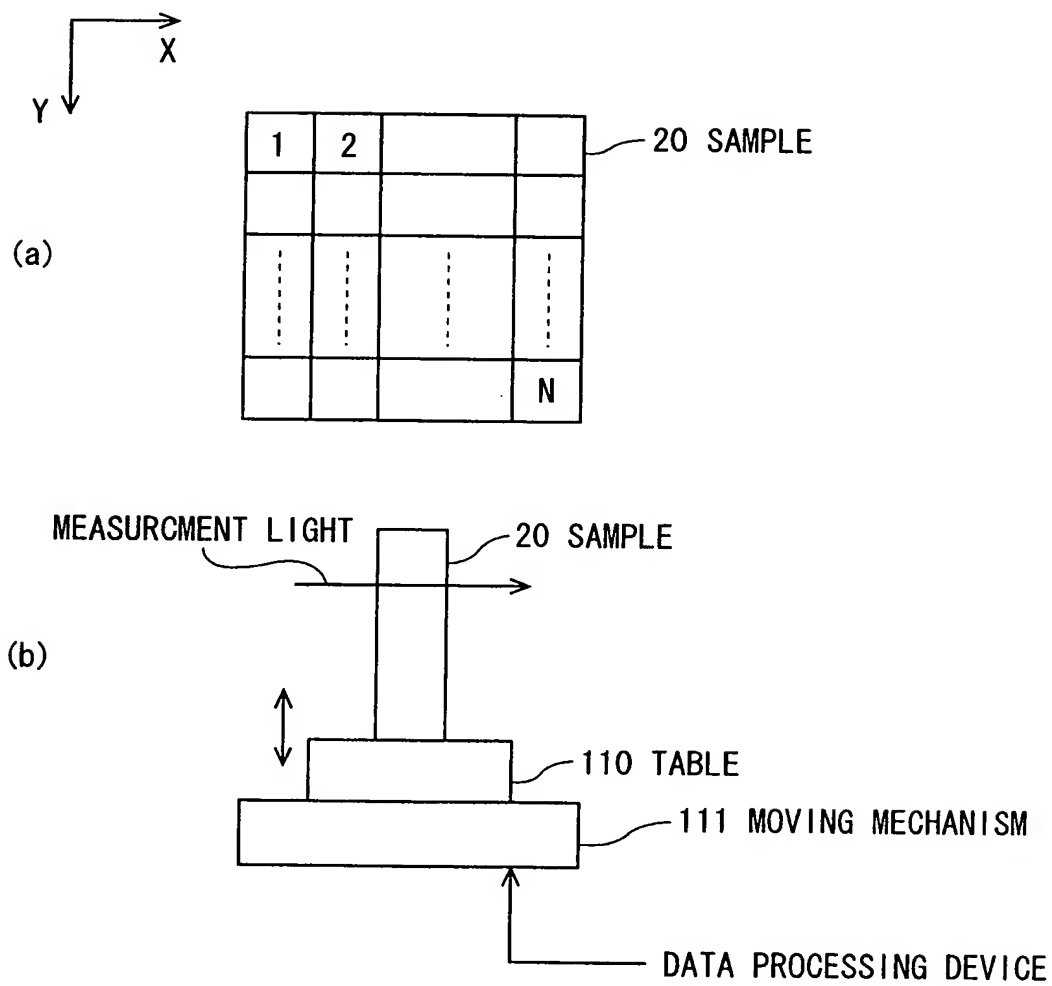
(b)



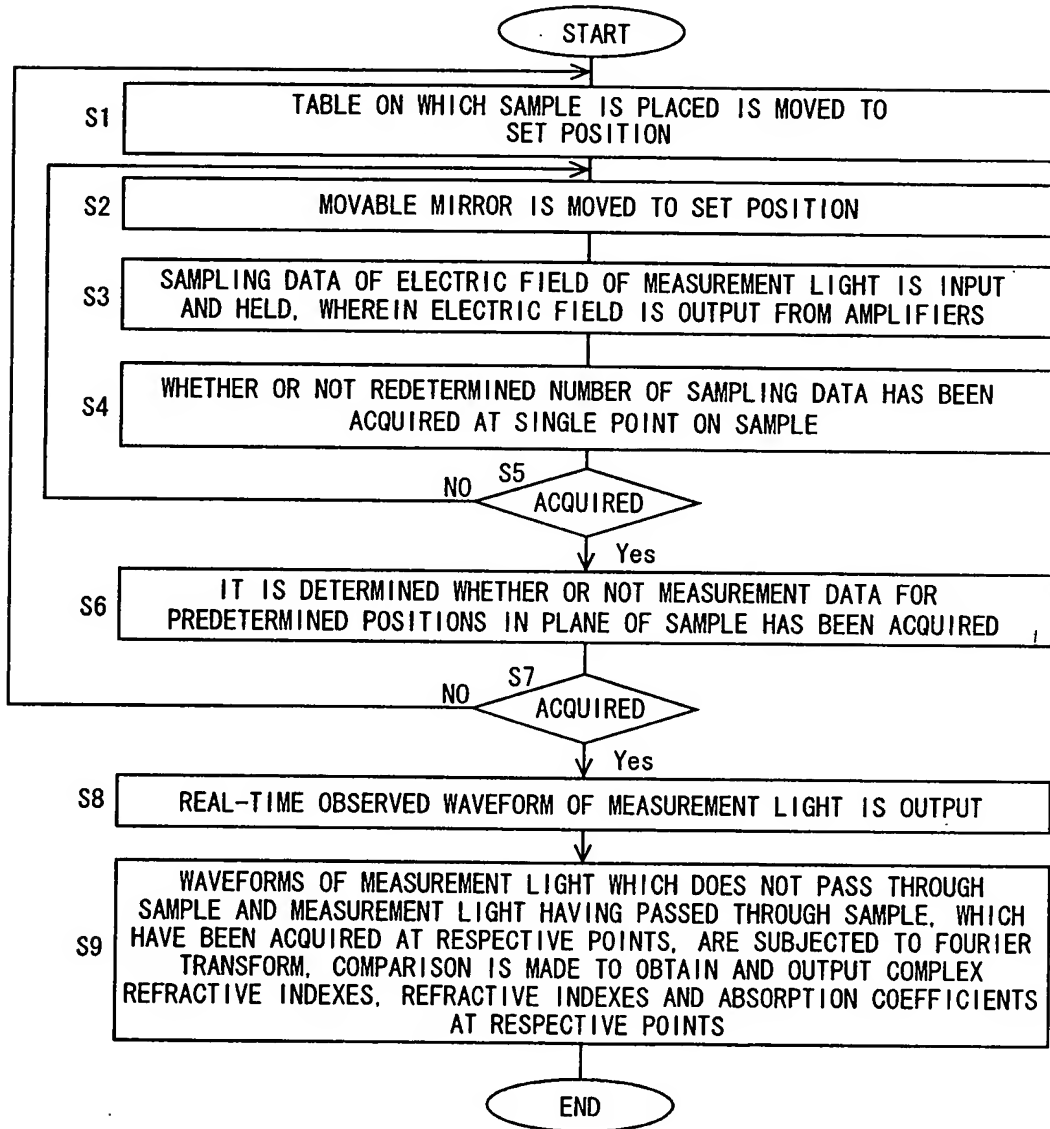
FLOW CHART IN DATA PROCESSING DEVICE ACCORDING TO FOURTH EMBODIMENT
OF THE INVENTION



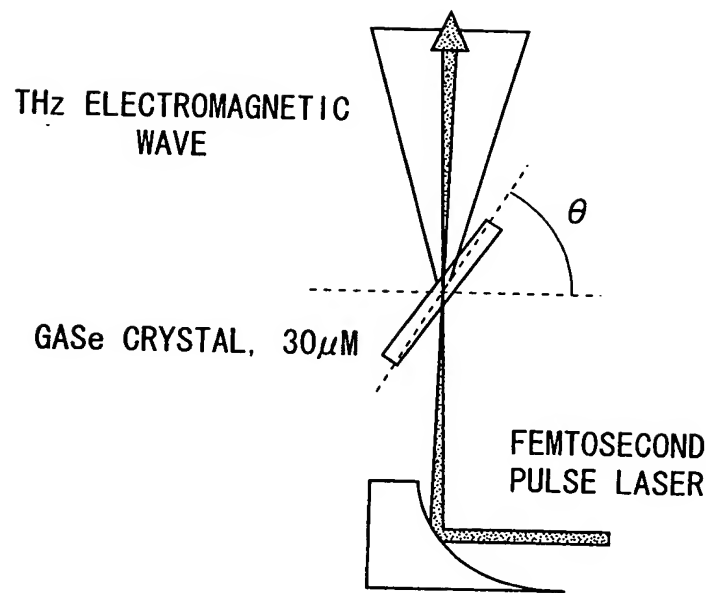
FIFTH EMBODIMENT



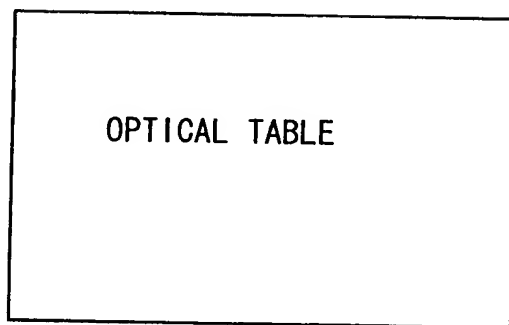
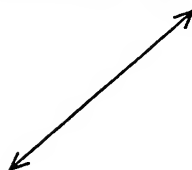
FLOW CHART IN DATA PROCESSING DEVICE ACCORDING TO FIFTH EMBODIMENT OF THE INVENTION



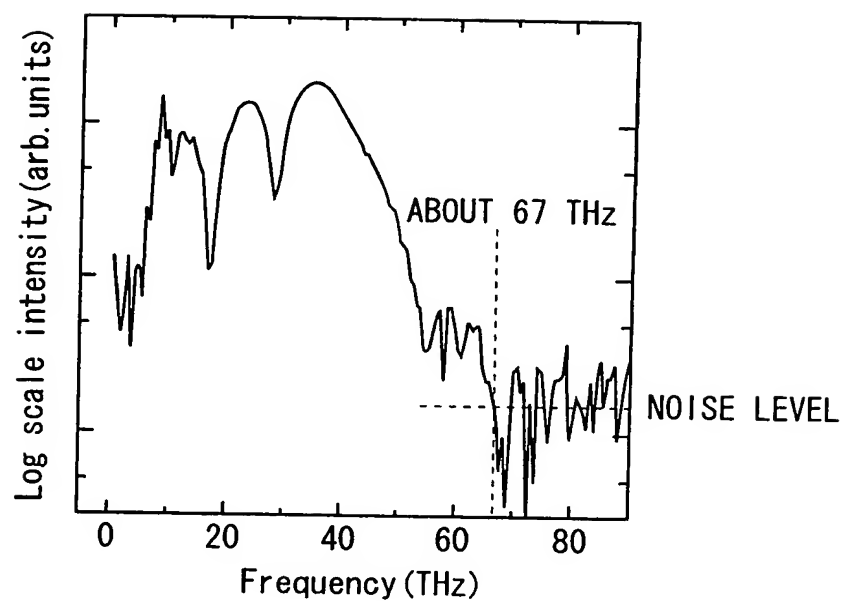
【図15】



DIRECTION OF POLARIZATION OF PULSE LIGHT



【図17】



EXPLANATION VIEW OF MEANS FOR SOLVING PROBLEMS

